



03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: H. Nguyen
RYUICHI EBINUMA, ET AL.)	
	:	Group Art Unit: 2851
Application No.: 09/817,018)	
	:	Confirmation No.: 7324
Filed: March 27, 2001)	
	:	Allowed: November 14, 2003
For: SUPPORTING STRUCTURE OF OPTICAL)	
ELEMENT, EXPOSURE APPARATUS	:	February 17, 2004
HAVING THE SAME, AND MANUFACTURING)	:	(Tuesday after Federal
METHOD OF SEMICONDUCTOR DEVICE	:	Holiday)

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

Sir:

Transmitted herewith are six (6) sheets of formal drawings, Figures 3, 5, 7-9 and 11, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

These formal drawings incorporate the changes requested by Applicants in a Request for Approval of Drawing Changes filed on April 24, 2003, which were subsequently approved by the Examiner in the Notice of Allowability dated November 14, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

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